L Number	Hits	Search Text	DB	Time stamp
1	5	(("5874361") or ("5868848") or ("5790365")	USPAT;	2003/10/01 15:14
_	· ·	or ("5665166") or ("6033482")).PN.	EPO; JPO	
_	8	(("5310453") or ("5529657") or ("5790365")	USPAT;	2003/09/05 21:10
	J	or ("5874361") or ("5904779") or	EPO; JPO	
		("5547539") or ("5458687") or		
		("6202590")).PN.		
_	9	(("5310453") or ("5529657") or ("5790365")	USPAT;	2003/09/05 13:55
	_	or ("5874361") or ("5904779") or	EPO; JPO	
		("5547539") or ("5458687") or ("6202590")	i	
		or ("5567267")).PN.		
_	547	(118/723r).CCLS.	USPAT	2003/09/05 13:57
_	1078	(118/728).ccls.	USPAT	2003/09/05 13:57
-	417	(361/234).CCLS.	USPAT	2003/09/05 13:57
-	310	(279/128).CCLS.	USPAT	2003/09/05 13:57
-	129	(156/345.43).CCLS.	USPAT	2003/09/05 13:58
- !	116	(156/345.44).CCLS.	USPAT	2003/09/05 13:58
-	58	(156/345.45).CCLS.	USPAT	2003/09/05 13:58
-	124	(156/345.46).CCLS.	USPAT	2003/09/05 13:58
-	154	(156/345.47).CCLS.	USPAT	2003/09/05 13:58
-	629	(315/111.21).CCLS.	USPAT	2003/09/05 13:58
-	206	(156/345.51).CCLS.	USPAT	2003/09/05 14:30
-	757518	h011021\$.ipc. c23c016\$.ipc.	JPO;	2003/09/17 14:42
			DERWENT	
-	11379	(h011021\$.ipc. c23c016\$.ipc.) and	JPO;	2003/09/05 15:58
		(detect\$3 measur\$5 sens\$3 test\$3) with	DERWENT	
		(charge\$2 impedance\$2 voltage\$2		
		capacitance\$2)		
-	2768	((h011021\$.ipc. c23c016\$.ipc.) and	JPO;	2003/09/05 14:33
		(detect\$3 measur\$5 sens\$3 test\$3) with	DERWENT	
		(charge\$2 impedance\$2 voltage\$2		
		capacitance\$2)) and (electrode\$2 cathode\$2	•	
		anode\$2)	_	
-	129	(((h011021\$.ipc. c23c016\$.ipc.) and	JPO;	2003/09/05 16:00
		(detect\$3 measur\$5 sens\$3 test\$3) with	DERWENT	
		(charge\$2 impedance\$2 voltage\$2		
		capacitance\$2)) and (electrode\$2 cathode\$2		
		anode\$2)) and ((remov\$3 releas\$3 dechuck\$3		
		chuck\$3) with (wafer substrate object		
		work))	1.00	0000/00/05 15 46
-	9	(((h011021\$.ipc. c23c016\$.ipc.) and	JPO;	2003/09/05 15:46
		(detect\$3 measur\$5 sens\$3 test\$3) with	DERWENT	
		(charge\$2 impedance\$2 voltage\$2		
		<pre>capacitance\$2)) and (electrode\$2 cathode\$2 anode\$2)) and ((detach\$3) with (wafer</pre>		
		anode\$2)) and ((detacn\$3) with (water substrate object work))		
_,	3	((((h011021\$.ipc. c23c016\$.ipc.) and	JPO;	2003/09/05 15:46
	3	((((noilozi;.ipc. ezsecit;.ipc.) and (detect\$3 measur\$5 sens\$3 test\$3) with	DERWENT	2000/00/00 10.40
		(charge\$2 impedance\$2 voltage\$2	DEKNENI	
		capacitance\$2)) and (electrode\$2 cathode\$2		
		anode\$2)) and ((detach\$3) with (wafer		
		substrate object work))) not		
		((((h011021\$.ipc. c23c016\$.ipc.) and		
		(detect\$3 measur\$5 sens\$3 test\$3) with		
		(charge\$2 impedance\$2 voltage\$2		
		capacitance\$2)) and (electrode\$2 cathode\$2		
		anode\$2)) and ((remov\$3 releas\$3 dechuck\$3		
		chuck\$3) with (wafer substrate object		
		work)))		
_	97	(156/345.28).CCLS.	USPAT	2003/09/05 15:57
_	0	("456789101112131416").PN.	USPAT	2003/09/05 15:58
-	3596	((118/723e).CCLS.) ((118/723r).CCLS.)	USPAT;	2003/09/05 15:58
		((118/728).CCLS.) ((361/234).CCLS.)	EPO; JPO	
		((279/128).CCLS.) ((156/345.43).CCLS.)		
			I	
		((156/345.44).CCLS.) ((156/345.45).CCLS.)		
		((156/345.44).CCLS.) ((156/345.45).CCLS.) ((156/345.46).CCLS.) ((156/345.47).CCLS.)		

-	922	(((118/723e).CCLS.) ((118/723r).CCLS.)	USPAT	2003/09/17 14:42
		((118/728).CCLS.) ((361/234).CCLS.)		
	1	((279/128).CCLS.) ((156/345.43).CCLS.)		
		((156/345.44).CCLS.) ((156/345.45).CCLS.)		
		((156/345.46).CCLS.) ((156/345.47).CCLS.)		
1		((315/111.21).CCLS.) ((156/345.51).CCLS.))		
		and (control\$4 monitor\$3 detect\$3 measur\$5		
		sens\$3 test\$3) with (charge\$3 impedance\$2		
1	1.50	voltage\$2 capacitance\$2)	71CD7M	2003/09/05 16:02
-	468	((((118/723e).CCLS.) ((118/723r).CCLS.)	USPAT	2003/09/03 16:02
		((118/728).CCLS.) ((361/234).CCLS.) ((279/128).CCLS.) ((156/345.43).CCLS.)		
		((156/345.44).CCLS.) ((156/345.45).CCLS.)		
		((156/345.46).CCLS.) ((156/345.47).CCLS.)		
		((315/111.21).CCLS.) ((156/345.51).CCLS.))		
	İ	and (control\$4 monitor\$3 detect\$3 measur\$5		
		sens\$3 test\$3) with (charge\$3 impedance\$2		
		voltage\$2 capacitance\$2)) and ((detach\$3		
		remov\$3 releas\$3 dechuck\$3 chuck\$3) with		1
		(wafer substrate object work))		
-	12	(("6221155") or ("5534751") or ("6485602")	USPAT;	2003/09/05 21:12
		or ("6264788") or ("6074518") or	EPO; JPO	
		("5900103") or ("6089181") or ("6068729")		
		or ("4539068") or ("6149730") or		
_	950	("5356722") or ("5286297")).PN. (118/723e).CCLS.	USPAT	2003/09/17 13:33
-	417	(118/723e).CCLS.	USPAT	2003/09/17 13:33 2003/09/17 14:43
-	417	(361/234).CCLS.) and dechuck\$3	USPAT	2003/09/17 14:43
_	8	((118/723e).CCLS.) and dechuck\$3	USPAT	2003/09/17 17:27
_	18	156/345\$.ccls. and dechuck\$3	USPAT	2003/09/17 15:51
_	13	(156/345\$.ccls. and dechuck\$3) not	USPAT	2003/09/17 15:40
		(((118/723e).CCLS.) and dechuck\$3)		
-	31	(h011021\$.ipc. c23c016\$.ipc.) and	JPO;	2003/09/17 15:50
ļ		dechuck\$3	DERWENT	0000/00/17 17 00
-	98	((361/234).CCLS.) and (remov\$3 with charg\$3)	USPAT	2003/09/17 17:30
_	71	(((361/234).CCLS.) and (remov\$3 with	USPAT	2003/09/17 16:16
	/-	charg\$3)) not (((361/234).CCLS.) and	OSTAI	2003/03/1/ 10:10
		dechuck\$3)		
-	16	118/723\$.ccls. and dechuck\$3	USPAT	2003/09/17 15:52
_	8	(118/723\$.ccls. and dechuck\$3) not	USPAT	2003/09/17 15:52
		(((118/723e).CCLS.) and dechuck\$3)		
-	2	((118/723\$.ccls. and dechuck\$3) not	USPAT	2003/09/17 15:52
		(((118/723e).CCLS.) and dechuck\$3)) not		
	070	(156/345\$.ccls. and dechuck\$3)		0000/00/17 15 55
-	270	yamashita-toshihiro\$.in.	USPAT;	2003/09/17 15:55
			US-PGPUB; EPO; JPO;]
			DERWENT	
_	91	"applied materials".as. and dechuck\$3	USPAT	2003/09/17 15:56
-	55	("applied materials".as. and dechuck\$3)	USPAT	2003/09/17 15:56
1		not (((361/234).CCLS.) and dechuck\$3)		
-	50	(("applied materials".as. and dechuck\$3)	USPAT	2003/09/17 15:56
		not (((361/234).CCLS.) and dechuck\$3))		
		not (((118/723e).CCLS.) and dechuck\$3)		
-	63	ise-hirotoshi\$.in.	USPAT;	2003/09/17 17:19
			US-PGPUB;	
			EPO; JPO;	
_	40	((("applied materials".as. and dechuck\$3)	DERWENT USPAT	2003/09/17 15:59
	40	not (((361/234).CCLS.) and dechuck\$3)	OSEMI	2003/03/11 13:33
		not (((381/234).CCLS.) and dechuck\$3))		
1		not (156/345%.ccls. and dechuck\$3)		
_	97	(156/345.28).CCLS.	USPAT	2003/09/17 16:17
-	268	yamashita-toshihiro\$.in. not	USPAT;	2003/09/17 17:26
		ise-hirotoshi\$.in.	US-PGPUB;	
			EPO; JPO;	
			DERWENT	
-	607	(438/710).CCLS.	USPAT	2003/09/17 17:27
_	7	((438/710).CCLS.) and dechuck\$3	USPAT	2003/09/17 17:27
_	29	((438/710).CCLS.) and (remov\$3 with charg\$3)	USPAT	2003/09/17 17:30
L	L	CHaryyo,		L

4	7

-	27	(((438/710).CCLS.) and (remov\$3 with	USPAT	2003/09/17 17:36
		charg\$3)) not (((438/710).CCLS.) and		
		dechuck\$3)		
			HCDAM.	2003/09/17 17:37
-	9	(("6430022") or ("6377060") or ("6185085")	USPAT;	2003/09/11 17:31
	1	or ("6125025") or ("6104595") or	EPO; JPO	†
		("6075375") or ("5818682") or ("5459632")		ļ .
		or ("6447613")).PN.		
_	0	("voltagewithprobe").PN.	USPAT	2003/09/17 19:04
			USPAT	2003/09/17 19:04
-	0	("voltagewithprobe").PN.		r I
-	8437		USPAT	2003/09/17 19:04
-	17	((361/234).CCLS.) and (voltage with	USPAT	2003/09/17 19:08
		probe)	T	
_	12	((118/723e).CCLS.) and (voltage with	USPAT	2003/09/17 19:08
		probe)		
_	11	(((118/723e).CCLS.) and (voltage with	USPAT	2003/09/17 19:08
	1 **	probe)) not (((361/234).CCLS.) and	002	2000,00,00
	_	(voltage with probe))		0000 (00 (17 10 10
-	8	((361/234).CCLS.) and (dechuck\$3 same	USPAT	2003/09/17 19:10
		gap)		
_	2110	118/728.ccls. 118/723e.ccls.	USPAT	2003/09/22 17:53
		156/345.43.ccls. 156/345.47.ccls.		1
		156/345.51.ccls.		[
	1504	(118/728.ccls. 118/723e.ccls.	USPAT	2003/09/22 17:53
-	1 1504		JOSEAL	2000/03/22 17.00
		156/345.43.ccls. 156/345.47.ccls.		1
	1	156/345.51.ccls.) and plasma		
-	372	((118/728.ccls. 118/723e.ccls.	USPAT	2003/09/30 18:49
		156/345.43.ccls. 156/345.47.ccls.		
		156/345.51.ccls.) and plasma) and chuck		
	249		USPAT	2003/09/30 18:41
	237	156/345.43.ccls. 156/345.47.ccls.	002111	2000,00,00 #0112
-	1	156/345.51.ccls.) and plasma) and chuck)		
		and (inductance capacitance impedance		
		voltage)		
-	174	((((118/728.ccls. 118/723e.ccls.	USPAT	2003/09/30 18:09
	1	156/345.43.ccls. 156/345.47.ccls.		
	1	156/345.51.ccls.) and plasma) and chuck)		
	1	and (inductance capacitance impedance		
		voltage)) and (detect\$5 measur\$5 sens\$5	1	
		monitor\$5)		
			TI CIDAM	2003/09/22 17:57
_	45	(((118/728.ccls. 118/723e.ccls.	USPAT	2003/09/22 17:37
	į.	156/345.43.ccls. 156/345.47.ccls.		
		156/345.51.ccls.) and plasma) and chuck)		
		and ((inductance capacitance impedance		1
	1	voltage) with (detect\$5 measur\$5 sens\$5		
		monitor\$5))		
_	72		USPAT	2003/09/30 17:32
	1 '2	156/345.43.ccls. 156/345.47.ccls.	332111	2000,00,00 1,.02
	İ			
	1	156/345.51.ccls.) and plasma) and chuck)		
	1	and ((inductance capacitance impedance		
		voltage) same (detect\$5 measur\$5 sens\$5		
	1	monitor\$5))		
-	175	((((118/728.ccls. 118/723e.ccls.	USPAT;	2003/09/30 18:09
		156/345.43.ccls. 156/345.47.ccls.	DERWENT	
		156/345.51.ccls.) and plasma) and chuck)		
	1	and (inductance capacitance impedance		
1	1	voltage)) and (detect\$5 measur\$5 sens\$5		
				j
	1	monitor\$5)	l uanam	2003/00/30 10 00
-	103	(((((118/728.ccls. 118/723e.ccls.	USPAT;	2003/09/30 18:09
		156/345.43.ccls. 156/345.47.ccls.	DERWENT]
		156/345.51.ccls.) and plasma) and chuck)		
		and (inductance capacitance impedance]
		voltage)) and (detect\$5 measur\$5 sens\$5]
		monitor\$5)) not ((((118/728.ccls.		
		118/723e.ccls. 156/345.43.ccls.		ļ i
1		156/345.47.ccls. 156/345.51.ccls.) and		1
İ	1	plasma) and chuck) and ((inductance		<u> </u>
	1			1
	1	capacitance impedance voltage) same		[
L	1	(detect\$5 measur\$5 sens\$5 monitor\$5)))	1	

	251	(((118/728.ccls. 118/723e.ccls.	USPAT;	2003/09/30 18:41
-	251	156/345.43.ccls. 156/345.47.ccls.	DERWENT	2003/03/30 10.41
		156/345.51.ccls.) and plasma) and chuck)	DEKWENT	
		156/545.51.CCIS.) and plasma) and chuck)		
		and (inductance capacitance impedance		
		voltage)	TTODAM.	2003/09/30 18:42
-	76	1 (((((((((((((((((((USPAT; DERWENT	2003/09/30 18:42
		156/345.43.ccls. 156/345.47.ccls.	DERWENT	
Ì		156/345.51.ccls.) and plasma) and chuck)		
		and (inductance capacitance impedance		
		voltage)) not (((((118/728.ccls.		
		118/723e.ccls. 156/345.43.ccls.		1
		156/345.47.ccls. 156/345.51.ccls.) and		
		plasma) and chuck) and (inductance		
ĺ		capacitance impedance voltage)) and		
		(detect\$5 measur\$5 sens\$5 monitor\$5))		0000 /00 /00 10 10
-	374	((118/728.ccls. 118/723e.ccls.	USPAT;	2003/09/30 18:49
		156/345.43.ccls. 156/345.47.ccls.	DERWENT	+
		156/345.51.ccls.) and plasma) and chuck		
-	123	((== : / = : - : - /)	USPAT;	2003/09/30 19:17
		156/345.43.ccls. 156/345.47.ccls.	DERWENT	
		156/345.51.ccls.) and plasma) and chuck)		1
		not ((((118/728.ccls. 118/723e.ccls.		1
		156/345.43.ccls. 156/345.47.ccls.		
	ŀ	156/345.51.ccls.) and plasma) and chuck)		
		and (inductance capacitance impedance		1 1
		voltage))		
_	15	(("5665166") or ("5665167") or ("5708250")	USPAT;	2003/09/30 19:23
		or ("5868848") or ("6033482") or	EPO; JPO	
		("6174450") or ("6367413") or ("5478429")	-	1
		or ("5584971") or ("5557215") or		
		("6201208") or ("6232236") or ("6109896")	<u> </u>	ŀ
		or ("5529657") or ("6416618")).PN.		1
-	15	(("5665166") or ("5665167") or ("5708250")	USPAT;	2003/09/30 19:23
		or ("5868848") or ("6033482") or	EPO; JPO	
		("6174450") or ("6367413") or ("5478429")		
		or ("5584971") or ("5557215") or		!
		("6201208") or ("6232236") or ("6409896")		1
		or ("5529657") or ("6416618")).PN.		1